

Letter of Authorization

Shenzhen AtomStack Technologies Co., Ltd.

Company: Shenzhen AtomStack Technologies Co., Ltd.

Address: 17th Floor, Building 3A, Phase II, Intelligent Park, No. 76, Baohe Avenue, Shenzhen, China

Product Name: Laser Engraver

Model Number: Atelier, L1, L2, L3, K1 Lite, K2 Lite, K3 Lite, P1, P1 Pro, P2, P2 Pro, X1, Fusion

FCC Identifier: 2BC9I-ATELIER

We authorize LGAI Technological Center S.A., Ronda de la Font del Carme, s/n, 08193 Bellaterra, Spain, to act on our behalf on all matters concerning the above named equipment.

Any individual within LGAI Technological Center S.A. is authorized to act on our behalf and take action on the application.

We declare that authorize LGAI Technological Center S.A., Ronda de la Font del Carme, s/n, 08193 Bellaterra, Spain, is allowed to forward all information related to the approval project to the Federal Communication Commission and to discuss any issues concerning the approval application. Any and all acts carried out by LGAI Technological Center S.A. on our behalf shall have the same effect as acts of our own.

Name: Jason Li Date: September 3, 2025

Title: CEO

Signature of applicant:

Jason LI